CUTTING EDGE OF SURFACE SCIENCE FOR ATOMIC SCALE APPROACH TO CATALYSTS

Registration fee: Free

Date: November 5, 2020 Time: 16:00-18:10 (JST)

Website: https://sites.google.com/ view/ijs-surface-science





Yujin Tong FHI & University of **Duisburg-Essen**



Satoru Takakusagi **Hokkaido University**



Tohoku University

Greeting, 16:00

K. Asakura (ICAT)

T. Kumagai(FHI & IMS)

Probing the electron and its ultrafast dynamics at the electrified 16:05 interface with a novel optoelectronic method Yujin Tong (FHI & University of Duisburg-Essen)

Atomic-level visualization of surface catalytic reactions by in-16:45 situ/operando XAFS and STM Satoru Takakusagi (ICAT, Hokkaido University)

Graphene growth on carbon-doped Ni substrate by surface 17:25 segregation Tadashi Abukawa (SRIS & IMRAM, Tohoku University)

Closing, A. Muramatsu (SRIS & IMRAM, Tohoku University) 18:05

Organizers: K. Asakura (ICAT), T. Kumagai (FHI & IMS), A. Muramatsu (SRIS & IMRAM), J. Hasegawa (ICAT) Sponsorship: Institute for Catalysis(ICAT), Hokkaido University

Department of Physical Chemistry, Fritz-Haber Institute (FHI)

Co-sponsorship: International Center for Synchrotron Radiation Innovation Smart (SRIS) & Institute of Multidisciplinary Research for Advanced Materials (IMRAM), Tohoku University Research Center for Artificial Photosynthesis, Osaka City University











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